

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q82315

Michel PUECH, et al

Appln. No.: 10/500,654

Group Art Unit: 1765

Confirmation No.: 2879

Examiner: Mahmoud DAHIMENE

Filed: July 2, 2004

For: A METHOD AND APPARATUS FOR ANISOTROPICALLY ETCHING SILICON
WITH A HIGH ASPECT RATIO

NOTICE OF APPEAL

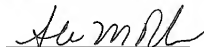
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the final
Office Action dated June 15, 2006.

Please charge the statutory fee of \$500.00 to Deposit Account No.: 19-4880. The
USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the
Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said
Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,



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Date: December 12, 2006